Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination
10/634,314	SAVAKIS ET AL.
Examiner	Art Unit
Shin-Lin Chen	1632

SEARCHED					
Class	Subclass	Date	Examiner		
435	455				
435	320.1				
424	93.2				
424	93.21				
536	23.1				
536	23.5				
536	24.1				
800	21				
800	278	9/16/2005	4		

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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